

AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 2886
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of	Docket No: Q85096
Masamichi INENAGA, et al.	
Appln. No.: 10/516,693	Group Art Unit: 2886
Confirmation No.: 6877	Examiner: Isiaka O. Akanbi
Filed: December 6, 2004	
For: WAFER PRE-ALIGNMENT APPARATUS AND METHOD	

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 11, 2008, please amend the above-identified application as follows on the accompanying pages.

TABLE OF CONTENTS

AMENDMENTS TO THE CLAIMS	2
REMARKS	5